

SANZ-253 (10403308)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s)

Lopp, et al.

Serial No.

10/797,925

Filed

March 10, 2004

For

SPUTTER ARRANGEMENT WITH A MAGNETRON AND

A TARGET

Art Unit

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Examiner

April 12, 2004

Commissioner for Patents P. O. Box 1450 Alexandria, VA. 22313-1450

## INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

US. Patent 5,213,672 is equivalent to DE 41 17 518 A1.

While the information and references disclosed in this Information Disclosure Statement may be "material" pursuant to 37 CFR 1.56, it is not intended to constitute an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Commissioner is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 50-0624, under Order No. NY-SANZ-253-US. A duplicate copy of this paper is enclosed.

Respectfully submitted,

FULBRIGHT & JAWORSKI L.L.P.

James R. Crawford

Reg. No. 39,155

666 Fifth Avenue New York, NY 10103 (212) 318-3148 Enclosures

Approved for use through 10/31/2002.OMB 0651-0031
U. S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number. Complete if Known Substitute for form 1449A/PTO 10/797,925 Application Number INFORMATION DISCLOSURE March 10, 2004 Filing Date STATEMENT BY APPLICANT First Named Inventor Lopp, et al. Art Unit (use as many sheets as necessary) Not Yet Assigned **Examiner Name** NY-SANZ-253 (10403308) Attorney Docket Number 1

of

	U.S. PATENT DOCUMENTS  Pages, Columns, Lines,							
Examiner Initials*	Cite No.1	Document Number  Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Where Relevant Passages or Relevant Figures Appear			
	AA	US-5,873,989	2/23/99	Hughes, et al.				
		US-5,213,672	5/25/93	Hartig, et al.				
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		FOREI	GN PATENT	DOCUMENTS		_
Examiner Initials*	Cite No.1	Foreign Patent Document  Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	⊤್
	AC	WO-96/21750	7/18/96	The BOC Group, Inc.		
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<sup>&</sup>lt;sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup> See attached Kinds Codes of USPTO Patent Documents at <a href="www.uspto.gov">www.uspto.gov</a> or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the application number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

	R ART – NON PATENT LITERATURE DOCUMENTS	
Plasm	Plasmatechnik, Grundlagen und anwendungen, 1984, p. 52-53	
Examiner Signature	Date Considered	

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>&</sup>lt;sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup>Applicant is to place a check mark here if English language Translation is attached.